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	First Named Inventor Hidehiko Kawaguchi						
	Art Unit		1746				
	Examiner Name	B. S.	S. Carrillo				
Attorney Docket Number		er	KAMMON 3.0-069 CONT				

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1	1	11082504	JP		1999-03-26	Nippon Seiko Kk	<i>y</i> .		×
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2	2	60034612	JP		1985-02-22	Toray Industries			×

U.S.PATENTS

ä	Application Number		10645773		
	Filing Date		2003-08-21		
INFORMATION DISCLOSURE	First Named Inventor	Hideh	niko Kawaguchi		
STATEMENT BY APPLICANT (Not for submission under 37 CER 1 99)	Art Unit		1746		
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